

<b>Notice of References Cited</b>	Application/Control No. 09/966,294	Applicant(s)/Patent Under Reexamination LAVRENTOVICH ET AL.	
	Examiner A. Sefer	Art Unit 2826	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,203,723	03-2001	Hsu, Ying Yen	252/299.01
	B	US-			
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	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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*	N	WO 96/06380	02-1996	PCT	Van Haaren et al.	
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
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